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The SIQUST Project Diamond-based single-photon sources as new quantum standards

Quantum Technologies within INFN: status and perspectives

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Single-photon sources

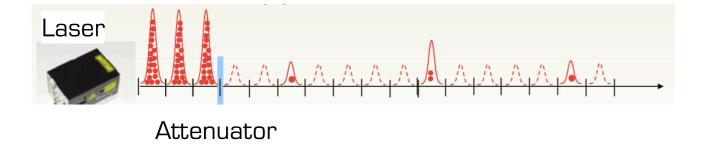
A single-photon source is a physical system which emits one photon on demand with given physical properties (polarization, wavelength)

Enables quantum information using photons

Probabilistic implementations

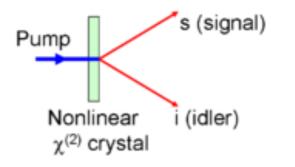
Attenuated lasers

Cheap Highly monochromatic High fraction of multi-photon (or no-photon) pulses



Parametric down-conversion

Conversion pump laser in entangled photon pairs Post-selection: detection of the idler Conversion process with small probability (<10⁻¹⁰)





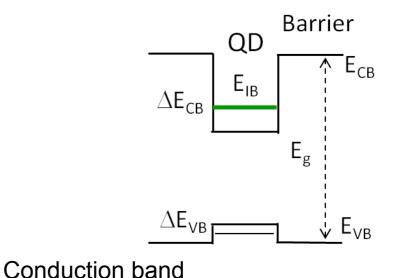
Solid-state single-photon sources

Quantum dots

Heterostructures, confinement, discrete energy levels Wavelength: tunable with the QD size Low temperature operation

Point defects in solids

Discrete energy levels in large band gap materials **Room temperature** operation Wavelength: system-dependent





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Valence band

AdvantagesDeterministic sources
Compact (chip) size, portability, mass production
Integration with existing micro-electronic technologies
Tunability of the quantum systems by materials engineeringChallengesFabrication strategies scalable to the industrial level
Significant retooling of ion implantation techniques
Driving solid state quantum systems
Environmental noise, temperature

Adequate single-photon detection systems

Lack of established standards (specs, quality control, industry)

The SIQUST Research Project

EURAMET European Association of National Metrology Institutes **EMPIR**: EU Metrology Programme for Innovation and Research Integrated within H2O2O scheme (2014-2020) Joint research projects involving

- Metrological Institutes
- Industrial Organizations
- Academia

"To bring Europan measurement science to an internationally leading position"

SIQUST: Single-photon sources as new quantum standards SIQUST Joint Research P

36 months (2018-2021), 1.8 M€ Consortium Budget

1. Solid state single-photon sources

10⁶ s⁻¹ rate, <2nm linewidth, 0.05 purity Quantum dots, diamond color centers, organic molecules

2. Novel sensing and measurement techniques

Based on new classes of SPSs and on entangled photons

3. Measurement infrastructure

Complete metrological characterization Traceability of detectors, amplifiers, radiometers Portable sources

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Project Leader

Physikalisch-Technische Bundesanstalt D

6 National Metrological Institutes

AALTO University	FIN
Metrosert	EST
National Physical Laboratories	UK
Czech Metrological Institute	CZ
<u>INRiM</u>	Ι

8 External Partners

VTT Technical Research Centre	FIN *
Technische Universität Berlin	D • 1
Universität des Saarlandes	D • 1
Universität Nürnberg	D • 1
Universität Stuttgart	D *
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INFN sez. Torino	
Consiglio Nazionale delle Ricerche	1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.
Consejo Superior de Investigaciones	s ES ·
Cientificas	





The SIQUST Activities in Torino





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F. Picollo P. Olivero











M. Genovese I. Degiovanni P. Traina

E. Bernardi E. Moreva

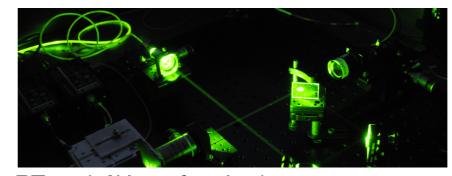


Cleanroom(s) for devices processing



Photolitography, laser milling Thermal processing, probe station

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RT and 4K confocal microscopy setups



5-100 kV ion implanter, Univ. Torino MIUR Dept. of Excellence Project Irradiation chamber embedded in cleanroom environment



The SIQUST Activities in Torino

Diamond based single-photon sources

Exploration of novel classes of emitters

- Fabrication methods, ion implantation
- Characterization of emission properties

Integration in opto-electronic devices

Electroluminescent sources Electrical tuning of emission spectra

Quantum enhanced sensing

NV center Electrometry Thermometry Bio-sensing

Alternative quantum emitters



Diamond color centers

Monoatomic crystal: control on defects formation

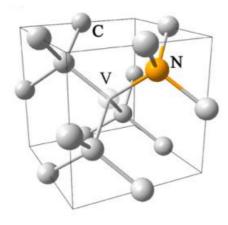
Point defects (vacancies, interstitials, substitutional impurities) Formation of discrete energy levels with optical transitions

- Individual defects: single-photon sources
- Large band gap (5.5 eV):
 - Emission in the visible light spectrum
 - Operation at high temperatures
- Hundreds of optically active defects

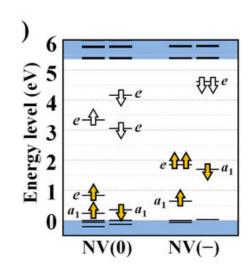
Many with high quantum efficiency and RT photo-stability

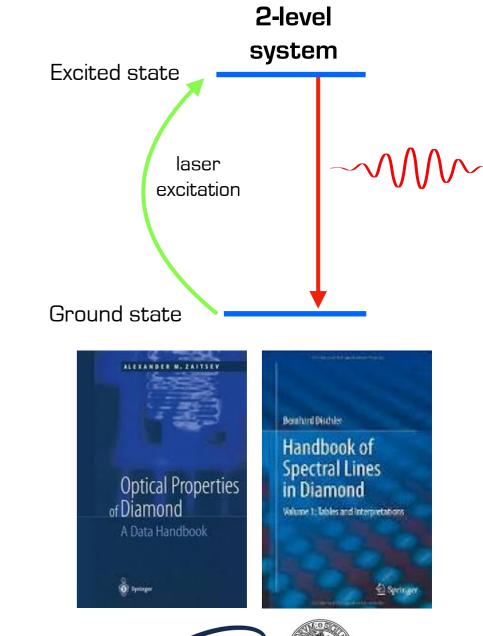
A systematic study is currently missing on

fabricability emission properties characterization



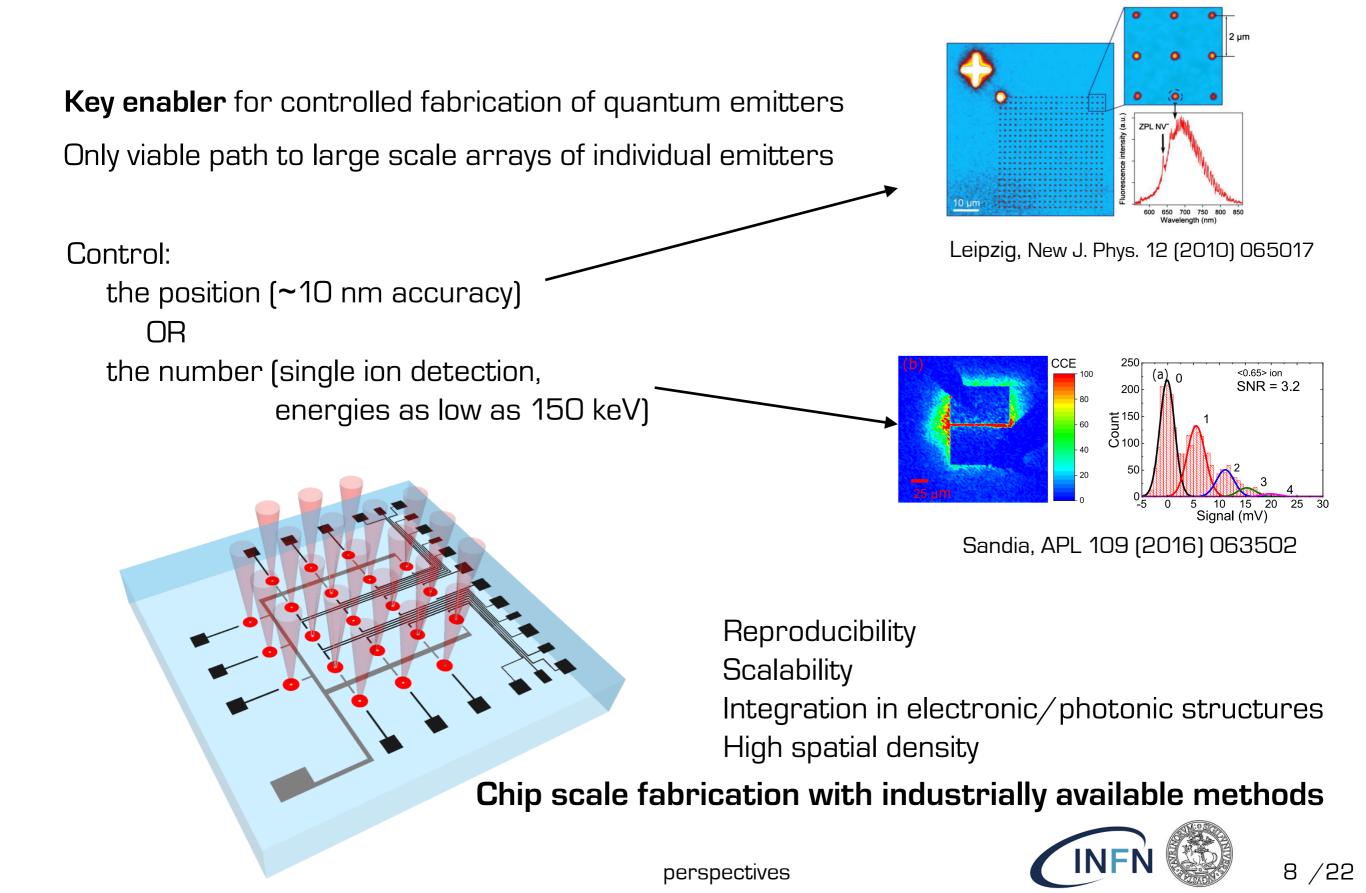
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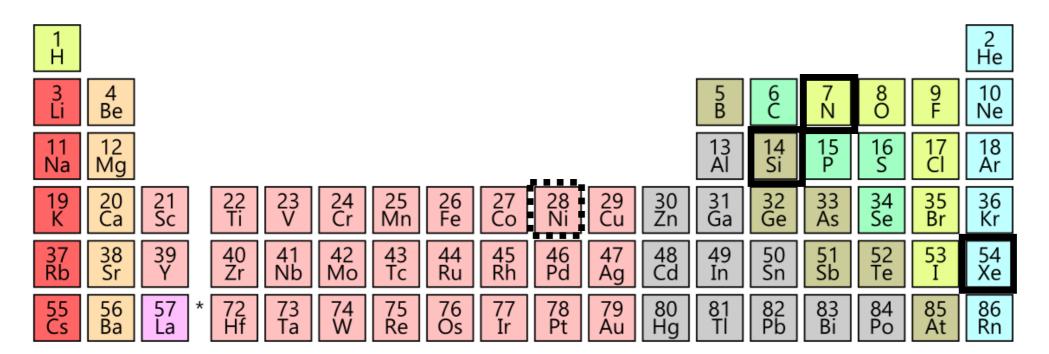


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Ion implantation of diamond color centers

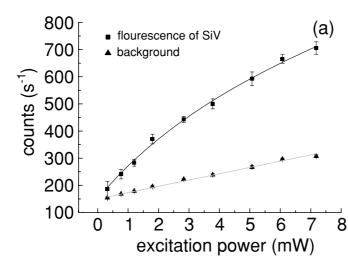


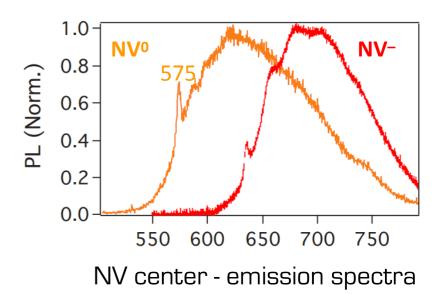
Quest for optimal quantum emitters



Luminescent defects in diamond fabricated upon ion implantation - 2014



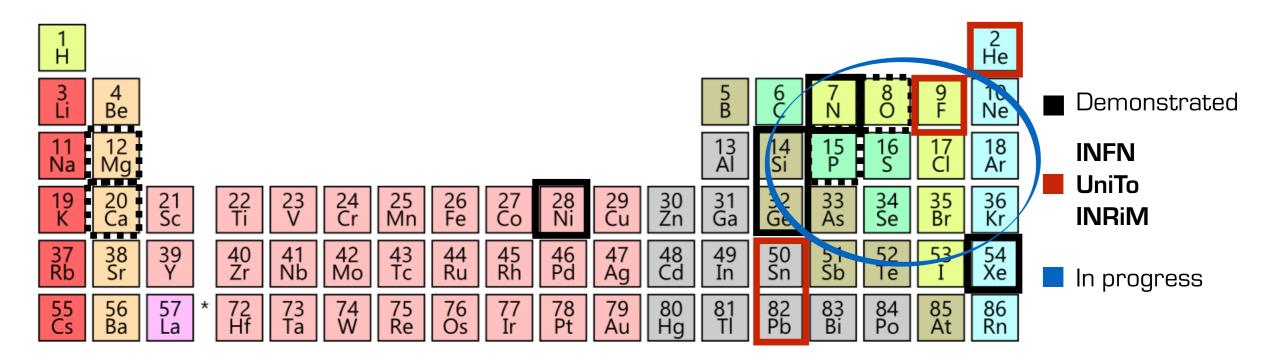




SiV center - RT emission intensity saturation



Quest for optimal quantum emitters



Luminescent defects in diamond fabricated upon ion implantation - 2019

NV center- J. Appl. Phys. 109, 083530 (2011)SiV center- J. Phys. B 39 (2006) 37Xe-center- J. Lumin 107 (2004) 26NE8 Center- J. Appl. Phys. 107 (2010) 093512

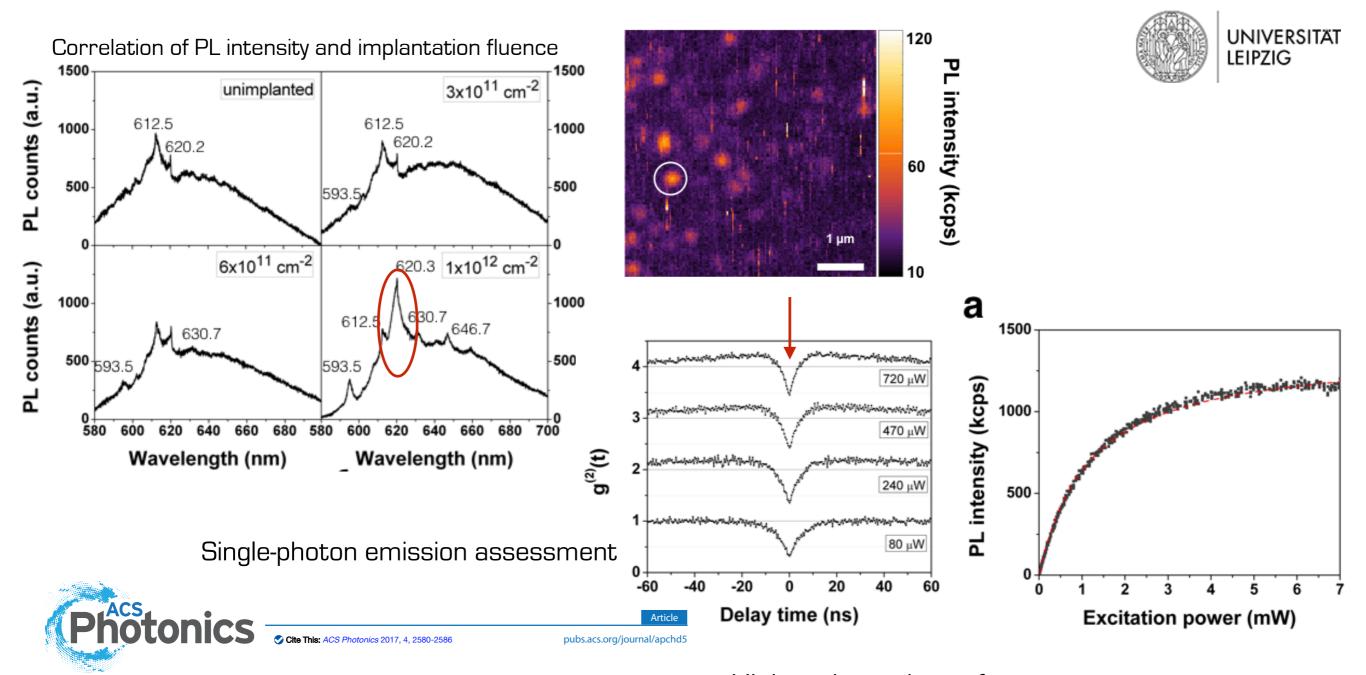
SnV center - ACS Phot. 4 (2017) 2580 - PRL 119, 253601 (2017) PbV center - ACS Phot. 5 (2018) 4864 He-center - J. Lumin 179 (2016) 59 F-center GeV center - Sci. Reports 5 (2015) 12882 - Sci. Reports 5 (2015) 14789

O-center- J. Phys. D 51 (2018) 483002P-centerLeipzig, ensembleCa-center- ImplementerMg-center- ImplementerF-center- Implementer



Demonstration of SnV center in diamond

20 keV, 10 MeV Sn implantation and annealing (T>900 $^\circ \rm C$) Main emission line at 620.3 nm



Single-Photon-Emitting Optical Centers in Diamond Fabricated upon Sn Implantation

S. Ditalia Tchernij,^{†,‡} T. Herzig,[§] J. Forneris,^{*,‡,†} J. Küpper,[§] S. Pezzagna,[§] P. Traina,^{\parallel} E. Moreva,^{\parallel} I. P. Degiovanni,^{\parallel} G. Brida,^{\parallel} N. Skukan,^{\perp} M. Genovese,^{‡, \parallel} M. Jakšić,^{\perp} J. Meijer,[§] and P. Olivero^{†,‡}

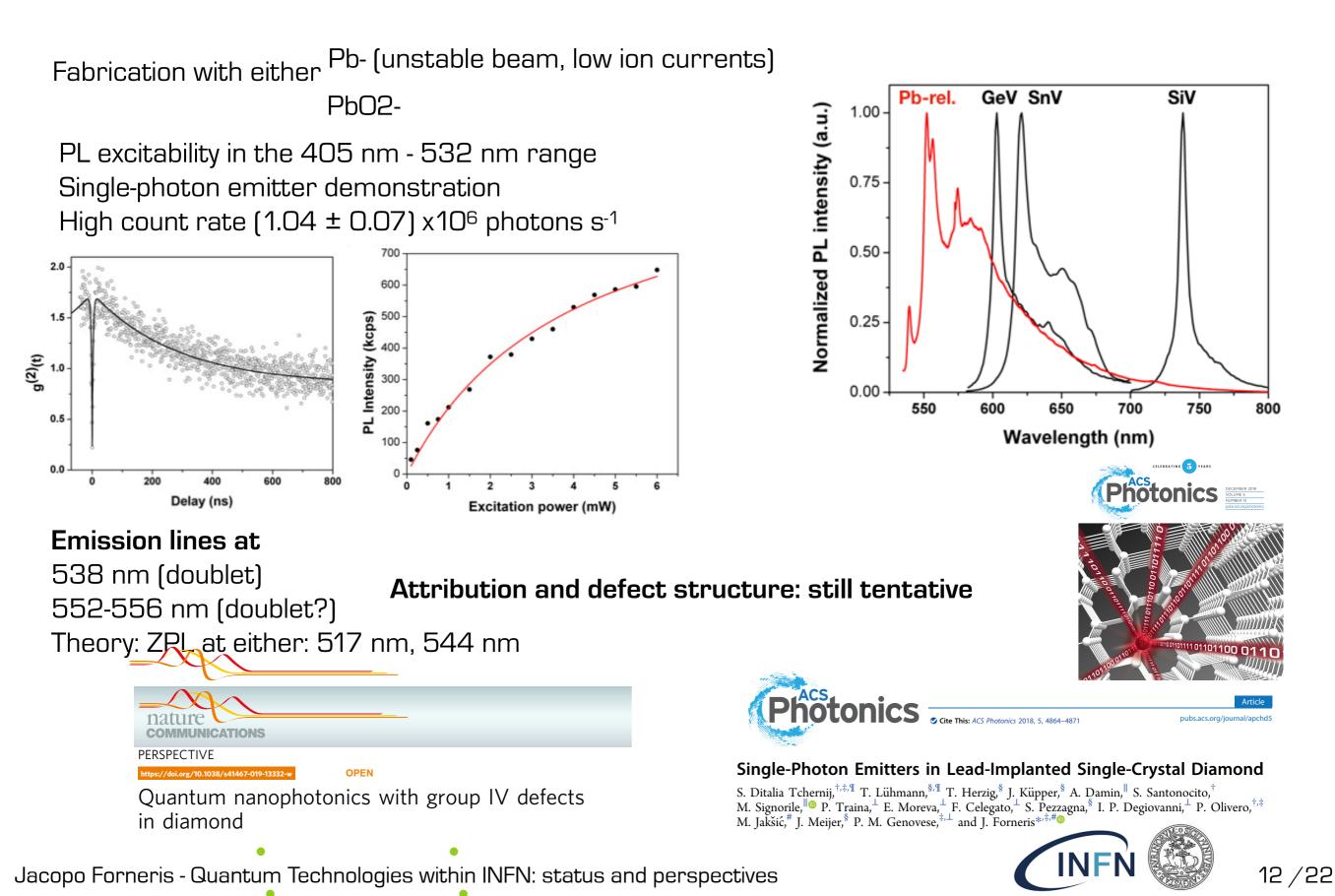
Highest intensity so far at room **temperature** Saturation emission: (1.37 ± 0.01) x10⁶ photons s⁻¹



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Pb-related emission in diamond





Optical activity of noble gases in diamond



0.1

0.01

0.001

0.1

0.01

0.1

0.01

800

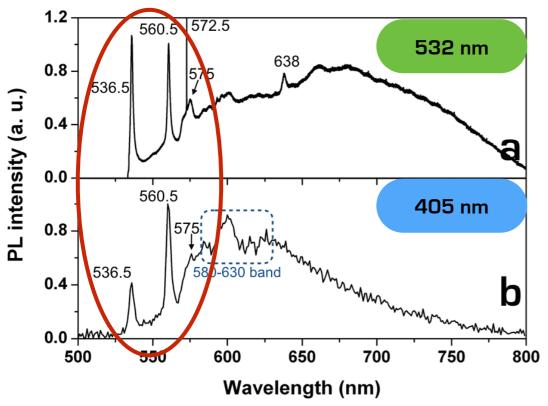
implanted

Optical activity of noble gases in diamond

Narrow lines at 535.5, 560.5 nm in He-implanted diamond (E>1 MeV, annealing at >750 °C)

0.1

0.0





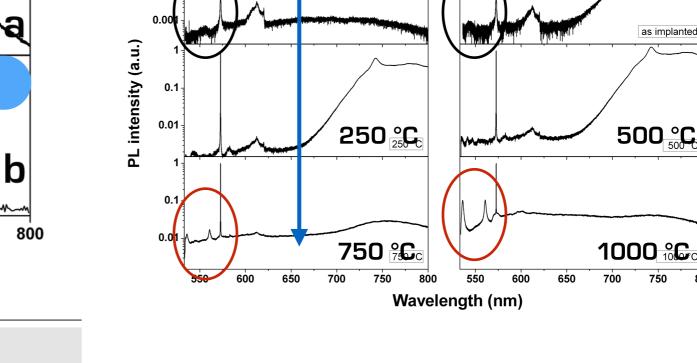
Contents lists available at ScienceDirect
Journal of Luminescence

journal homepage: www.elsevier.com/locate/jlumin

Full Length Article

Creation and characterization of He-related color centers in diamond

J. Forneris ^{a,b,c,*}, A. Tengattini ^{b,a,c}, S. Ditalia Tchernij ^{b,a,c}, F. Picollo ^{a,b,c}, A. Battiato ^{b,a,c}, P. Traina ^d, I.P. Degiovanni ^d, E. Moreva ^d, G. Brida ^d, V. Grilj ^e, N. Skukan ^e, M. Jakšić ^e, M. Genovese ^{a,c,d}, P. Olivero ^{b,a,c}



Ne, Xe-implanted diamond also exhibit CL lines, Phys. Stat. Sol. (b) 129 (1985) 129

Formation at T>750° C, concurrent

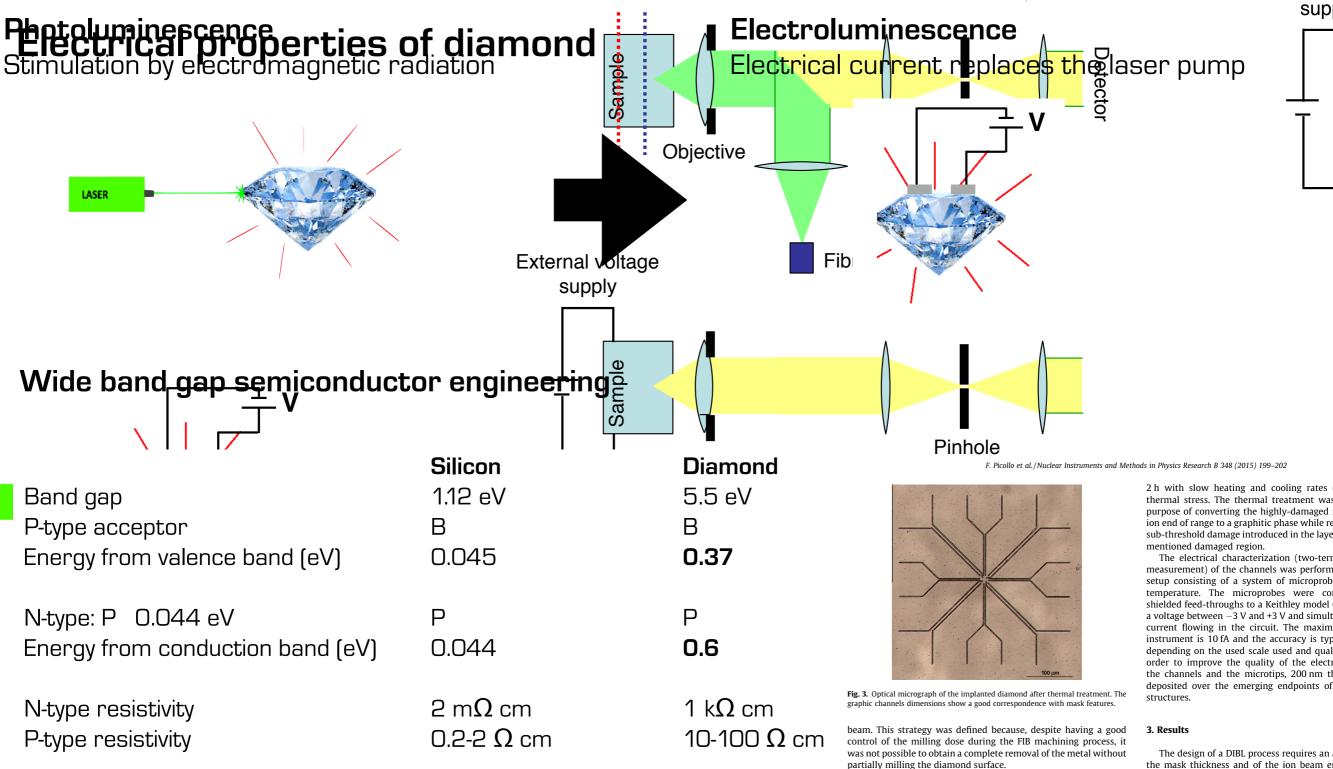
decrease in vacancies PL intensity

unimplanted

pristine



Efectrical stimulation disingle and doaned it emitte



Alternative strategies to doping are needed

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Graphitic channels buried into the diamond substrate were fabricated by ion implantation through the previously-described masks using a 1.8 MeV He⁺ broad-beam (~5 mm² spot size) with an ion current of ${\sim}500$ nA. The ion fluence was ${\sim}2\times10^{17}\,cm^{-2}$ and the sample was implanted at room temperature. Ion implantation was performed by using the 60° beam line at the AN2000 facility of the INFN National Laboratories of Leg

According to SRIM2013 Monte Carlo diation conditions are suitable for p profile with a damage peak well above (i.e., $9 \times 10^{22} \text{ cm}^{-3}$) [11].

SRIM simulatio

measurement) of the channels was perform setup consisting of a system of microprob temperature. The microprobes were con shielded feed-throughs to a Keithley model a voltage between -3 V and +3 V and simult

External

instrument is 10 fA and the accuracy is typ depending on the used scale used and qual order to improve the quality of the electric the channels and the microtips, 200 nm th deposited over the emerging endpoints of

The design of a DIBL process requires an the mask thickness and of the ion beam en process. These parameters can be established Carlo numerical simulations (see Fig. 2). Us chose the above reported values (mask t beam energy = 1.8 MeV) in order to fabric 3 um below the surface

shown in Fig. 2a, the Bragg peak of the cated within the copper layer, thus time, the FIB milled regions of the n ne ions. The **depth** p these areas is r

Electrical control of diamond quantum emitters

Deep Ion Beam Lithography

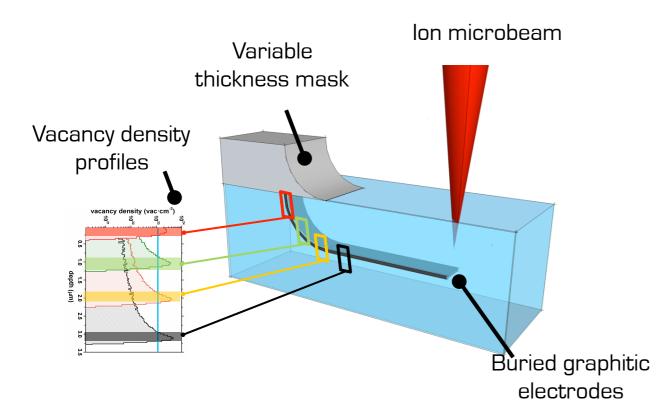
Exploitation of **MeV** ion nuclear energy loss

Cumulation of damage at the end of ion range

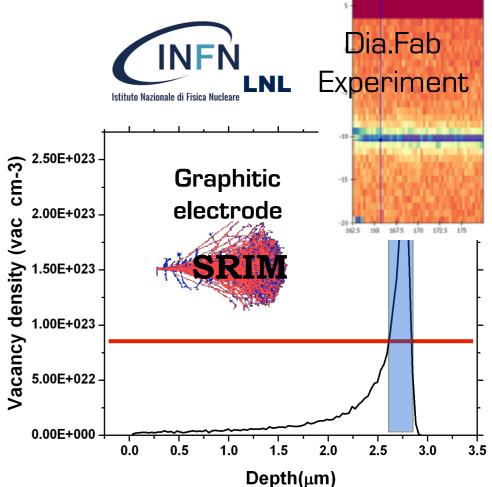
Amorphization of buried diamond layer

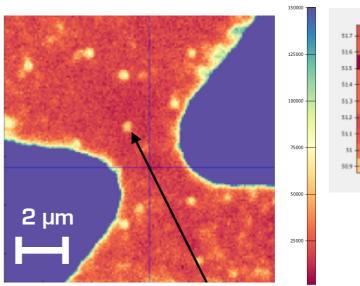
Thermal treatment: **Conductive channels** embedded in **insulating diamond**

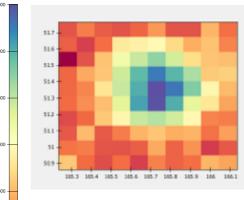
F. Picollo et al., New J. Phys. 14, 053011 (2012)



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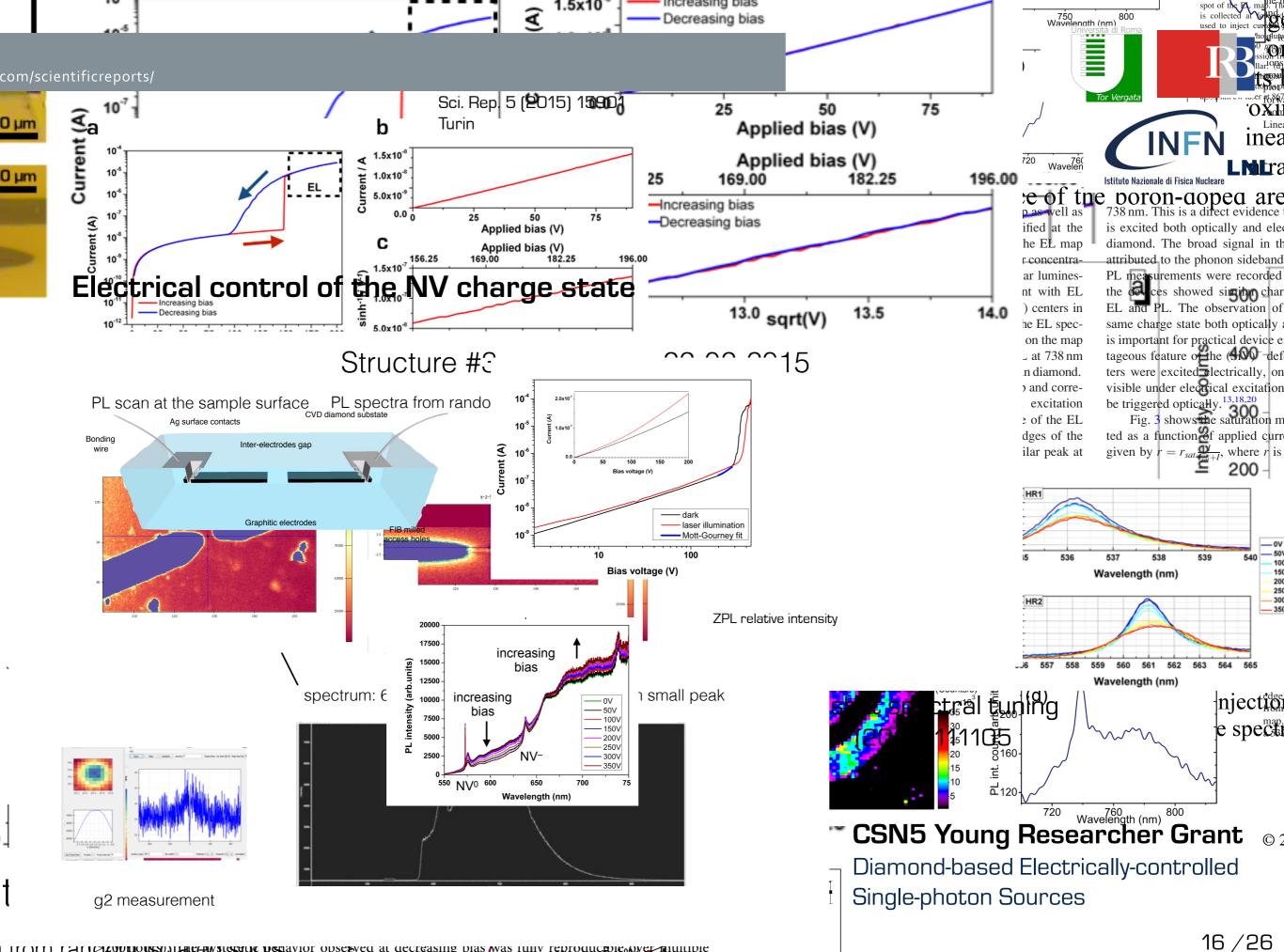






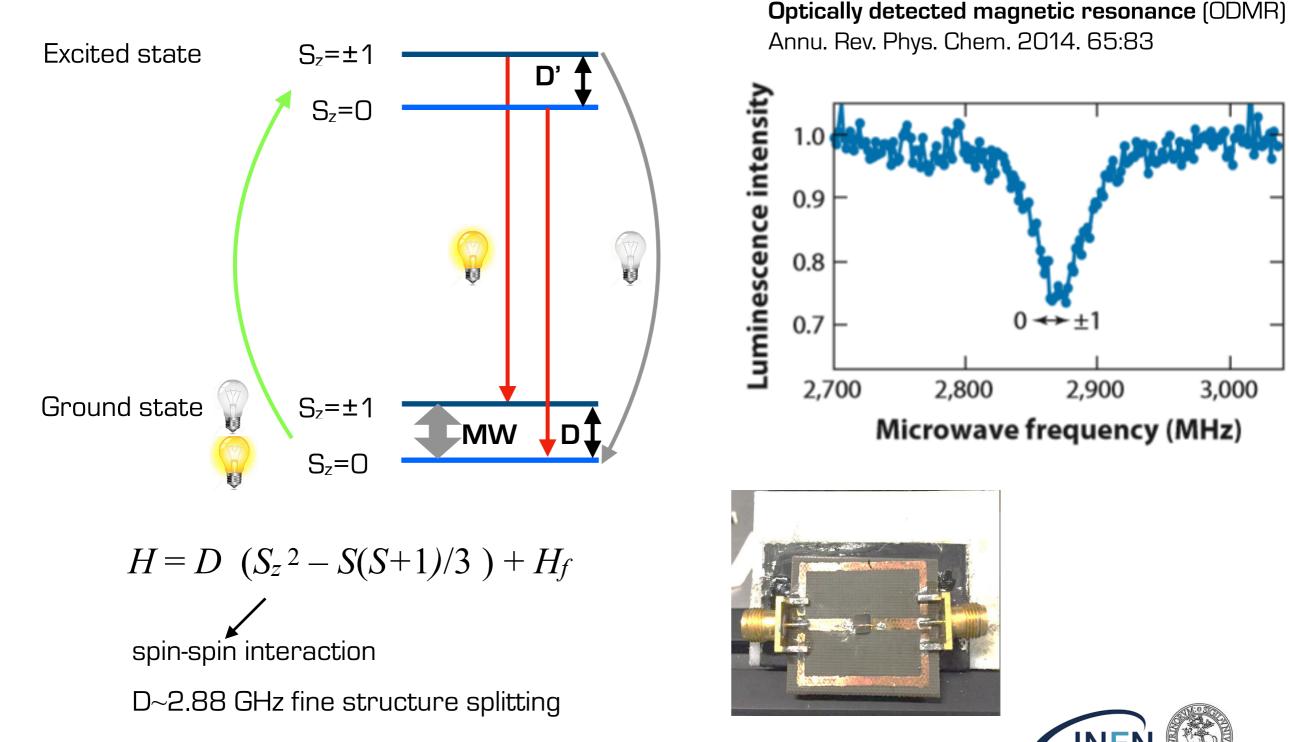


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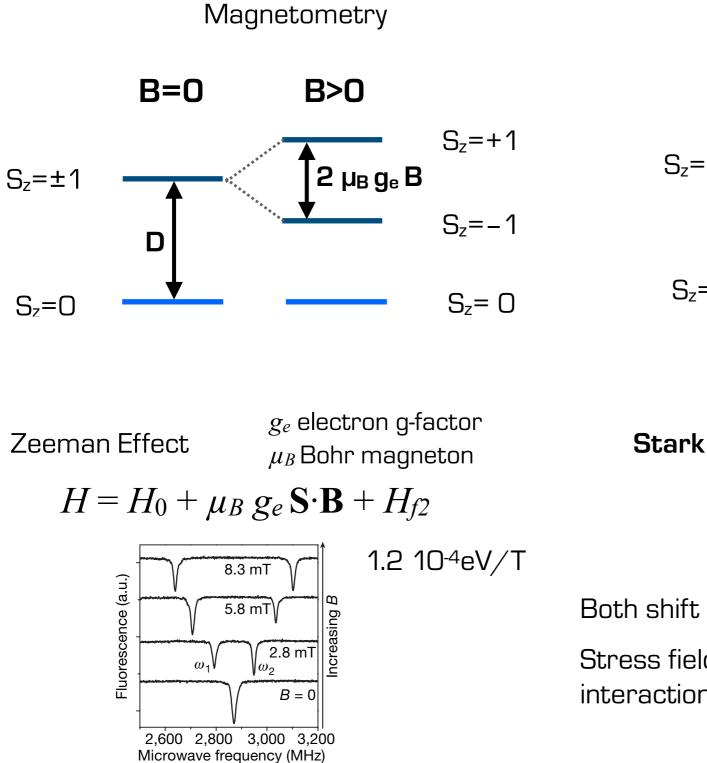
Diamond-based quantum sensing: the NV- center

Quantum information is encoded **in the emitting system** emission rate, wavelength depend on the interaction with environment

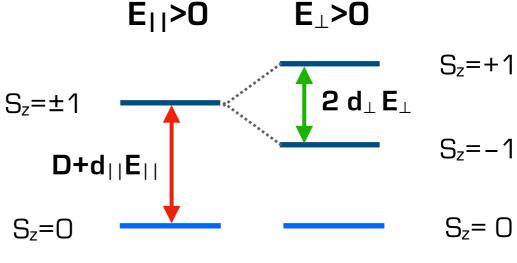




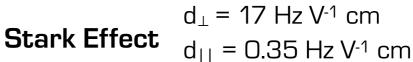
The NV- center as a nanoscale magnetometer



Electrometry







Both shift and splitting of the resonance frequencies

Stress fields (and thus temperature) display the same interaction Hamiltonian as electric field coupling

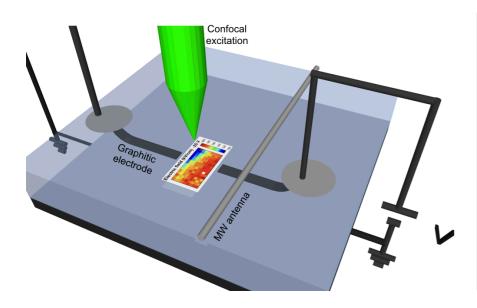


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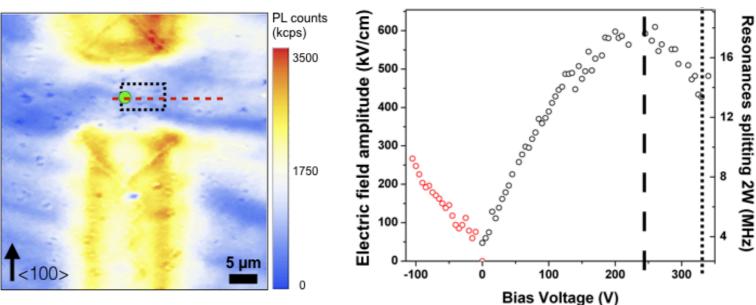
Electric field sensing: device diagnostics

Direct measurement and **mapping** of the internal electric field in diamond devices Experimental observation of **radiation-damage induced memory effects** diamond

NV ensembles



PL map of graphite-diamond-graphite junction



Internal electric field at the junction center vs applied external bias

PHYSICAL REVIEW APPLIED 10, 014024 (2018)

Mapping the Local Spatial Charge in Defective Diamond by Means of N-V Sensors—A Self-Diagnostic Concept

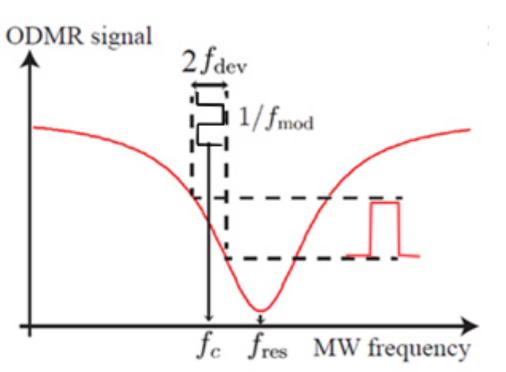


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Advanced temperature sensing



ODMR Resonance

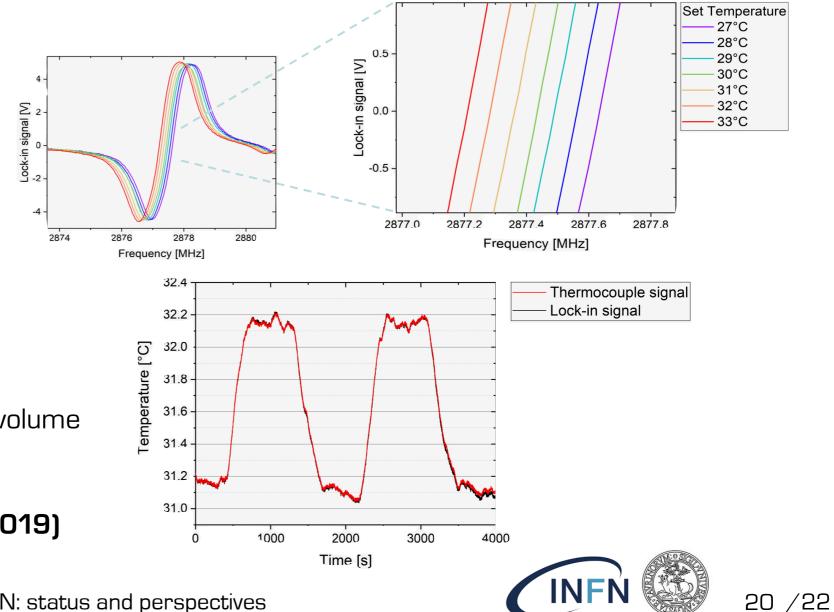


Sensitivity = $5 \text{ mK/Hz}^{1/2}$

Lock-in detection

Microwave excitation modulated by a square wave Photodiode signal detected by a lock-in amplifier Temperature-induced resonance shift -> lock-in signal variation

Lock-in Spectrum



Thermocouple 10⁻⁹ m³ volume NV centers ensemble: ~10⁻²⁰ sensing volume

E. Moreva et al., arXiv:1912.10887 (2019)

Summary

Diamond color centers

Promising platform for technologies

quest for optimal quantum emitters is still open need for scalable fabrication tools need for experimental techniques to assess defects structure and properties

Unique features for quantum sensing applications

high sensitivity at the lattice constant spatial scale magnetometry electrometry thermometry



Thank you for your kind attention!



UNIVERSITÀ DEGLI STUDI DI TORINO



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V. Rigato L. Latorre





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F. Jelezko B. Naydenov



Research Project "SIQUST" Single-photon sources as new quantum standards

